



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hideomi Suzawa et al. Art Unit : 2812
Serial No. : 09/852,672 Examiner : Alexander G. Ghyka
Filed : May 11, 2001 Confirmation No.: 5083
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

MAIL STOP RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

Submitted herewith is an English translation of the following foreign language references, or portions thereof:

Desig. ID	Source
ABBB	JAPAN 01-207973 – English Abstract: DIALOG® FILE 352:Derwent WPI (2001); Accession No. 008017742
ACCC	JAPAN 07-130652 – English Abstract: DIALOG® FILE 347:JAPIO (1998); Accession No. 04838052
ADDD	JAPAN 09-054318 – Full English language translation
AEEE	JAPAN 10-048640 – English Abstract: 1998, 2003 JAPAN PATENT OFFICE©
AFFF	JAPAN 10-073813 – English Abstract: DIALOG® FILE 347:JAPIO (2002); Accession No. 05790713
AGGG	JAPAN 10-326772 – English Abstract: DIALOG® FILE 352:Derwent WPI (2001); Accession No. 012285689
AHHH	JAPAN 11-258596 – English Abstract: DIALOG® FILE 352:Derwent WPI (2000); Accession No. 012788624
AIII	JAPAN 2000-047263 – English Abstract: esp@cenet database – Worldwide (2005): http://v3.espacenet.com/family?sf=n&FIRST=1&F=8&CY=ep&LG=en&PN=JP2000...
AJJJ	JAPAN 2001-085700 – English Abstract: esp@cenet database – Worldwide (2005): http://v3.espacenet.com/textdoc?DB=EPODOC&IDX=JP2001085700&F=8&QPN=...

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Attorney's Docket No.: 12732-038001 / US4917/4945

This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Respectfully submitted,

Date: June 13, 2005

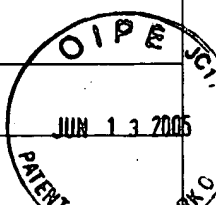


John F. Hayden
Reg. No. 37,640

Customer Number 26171
Fish & Richardson P.C.
1425 K Street, N.W., 11th Floor
Washington, DC 20005-3500
Telephone: (202) 783-5070
Facsimile: (202) 783-2331

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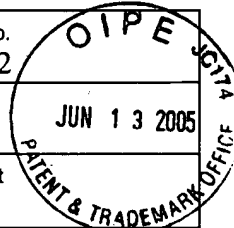
Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12732-038001	Application No. 09/852,672
	Applicant Hideomi Suzawa et al.		
	Filing Date May 11, 2001	Group Art Unit 2812	



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Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12732-038001	Application No. 09/852,672
	Applicant Hideomi Suzawa et al.		
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Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
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	ABBB	01-207973	08/21/1989	JAPAN			ABS	
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	AEEE	10-048640	02/20/1998	JAPAN			ABS	
	AFFF	10-073813	03/17/1998	JAPAN			ABS	
	AGGG	10-326772	12/08/1998	JAPAN			ABS	
	AHHH	11-258596	09/24/1999	JAPAN			ABS	
	AIII	2000-047263	02/18/2000	JAPAN			ABS	
	AJJJ	2001-085700	03/30/2001	JAPAN			ABS	

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AKKK	Badih El-Kareh; <i>Fundamentals of Semiconductor Processing Technologies</i> ; p. 285; 1998

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